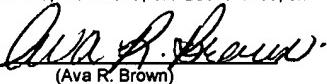


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Dated: November 3, 2005

Signature: 
(Ava R. Brown)

Docket No.: 08228/019001
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Shiro Sakai et al.

Application No.: 10/044,686

Art Unit: 1722

Filed: January 11, 2002

Examiner: Matthew J. Song

For: NITRIDE SEMICONDUCTOR CHIP AND
METHOD FOR MANUFACTURING NITRIDE
SEMICONDUCTOR CHIP

REPLY UNDER 37 C.F.R. 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated September 9, 2005, please reconsider this application in view of the following.